

Title (en)

METHOD FOR FORMING A FIBROUS LAYER

Title (de)

VERFAHREN ZUR HERSTELLUNG EINER FASERSCHICHT

Title (fr)

PROCÉDÉ DE FORMATION D'UNE COUCHE FIBREUSE

Publication

**EP 2643855 A1 20131002 (FR)**

Application

**EP 11794862 A 20111121**

Priority

- FR 1059661 A 20101124
- IB 2011055212 W 20111121

Abstract (en)

[origin: WO2012069981A1] The present invention relates to a method for forming, on the surface of one of the sides of a silicon substrate, a fibrous layer having a mean lattice pitch of no more than 2  $\mu\text{m}$ , without requiring soaking. The invention also relates to devices, in particular photovoltaic cells, comprising a silicon substrate produced by means of such a method.

IPC 8 full level

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See references of WO 2012069981A1

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DOCDB simple family (publication)

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